



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Sandhu et al.

Serial No.: 10/637,102

Filed: August 8, 2003

For: LOW RESISTANCE CONTACT TO
SILICON HAVING A TITANIUM SILICIDE
INTERFACE AND AN AMORPHOUS
TITANIUM CARBONITRIDE BARRIER
LAYER

Examiner: L. Gurley

Group Art Unit: 2812

Attorney Docket No.: 2269-3264.7US
(92-0280.10/US)

CERTIFICATE OF MAILING

I hereby certify that this correspondence along with any attachments referred to or identified as being attached or enclosed is being deposited with the United States Postal Service as First Class Mail on the date of deposit shown below with sufficient postage and in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 9, 2004
Date

Signature

Deidra Pfeil
Name (Type/Print)

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In compliance with the duty to disclose information material to patentability pursuant to 37 C.F.R. § 1.56, it is respectfully requested that this Supplemental Information Disclosure Statement be entered and the documents listed on attached Form PTO-1449 or PTO/SB/08 be considered by the Examiner and made of record. The listed documents are from co-pending application Serial No. 10/637,108, filed August 8, 2003. Copies of the listed documents are enclosed pursuant to 37 C.F.R. § 1.98(a).

In accordance with 37 C.F.R. § 1.97(g) and (h), filing of this Supplemental Information Disclosure Statement is not to be construed as a representation that a search has been made or an admission that the information cited herein is, or is considered to be, material to patentability as defined in 37 C.F.R. § 1.56(b). Further, no representation is made by Applicants herein that no other possible material information as defined in 37 C.F.R. § 1.56 (b) exists.

U.S. Patent Documents

<u>U.S. Patent No.</u>	<u>Publication Date</u>	<u>Patentee</u>
4,725,877	02/1988	Brasen et al.
4,804,636	02/1989	Groover et al.
5,770,520	06/1998	Zhao et al.
6,187,673	02/2001	Lai et al.
6,261,935	07/2001	See et al.
6,271,136	08/2001	Shue et al.
6,281,101	08/2001	Iyer

Applicants offer to supply any explanation or discussion of the documents which the Examiner feels is necessary or desirable and which is requested.

This Supplemental Information Disclosure Statement is filed after the mailing date of the first Office Action on the merits.

I hereby certify that no item of information contained in the Supplemental Information Disclosure Statement was first cited in any communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned after making reasonable inquiry, was known to any individual designated in 37 C.F.R. § 1.56(c) more than three months prior to the filing of the statement, and therefore no fee is due.

Respectfully submitted,



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Date: March 9, 2004
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Enclosures: Form PTO-1449 or PTO/SB/08
Copy of documents cited

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